



IFW

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasuhiro OMURA

Group Art Unit: 2882

Application No.: 10/587,254

Examiner: C. KREUTZER

Filed: June 1, 2007

Docket No.: 128834

For: OPTICAL SYSTEM, EXPOSURE SYSTEM, AND EXPOSURE METHOD

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the September 27, 2010 Office Action, and in view of the December 21, 2010 personal interview, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**